

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re DIVISIONAL PATENT APPLICATION OF

FUKAURA, Yasuhiro

Group Art Unit: 2818

Appln. No.: UNASSIGNED

Examiner: Dung Anh LE

Filed: HEREWITH

Atty Dkt 008312/0304361

C# M#

Title: METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE WITH GLUE LAYER
IN OPENING

June 24, 2003

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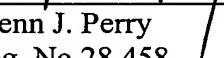
INFORMATION DISCLOSURE STATEMENT

Attached is Form PTO-1449 listing all of the documents cited by Applicant and the PTO in the parent application(s) relied upon under 35 USC 120. Per Rule 98(d) copies of those documents are not enclosed.

Please consider those documents and advise that they have been considered in this new application by returning a copy of the enclosed Form PTO-1449 with the Examiner's initials in the left column per MPEP 609. .

Respectfully submitted,

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FORM PTO-1449 (modified)
To: U.S. Department of Commerce
(PW FORM PAT-1449)
Patent and Trademark Office

Atty.
Dkt. No.

M#

Client Ref

0304361

T1TN-00S0006-D2

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Applicant: FUKAURA, Yasuhiro

Appln. No.: UNASSIGNED

Filing Date: June 24, 2003

Date: June 24, 2003

Page 1 of 1

Examiner: D. LE

Group Art Unit: 2818

U.S. PATENT DOCUMENTS

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR	5,683,924	11/1997	Chan et al.			
	BR	6,063,676	05/2000	Choi et al.			
	CR	6,124,627	09/2000	Rodder et al.			
	DR	6,127,233	10/2000	Rodder			
	ER	6,137,149	10/2000	Kodama			
	FR	5,930,620	07/1999	Wristers et al.			
	GR	6,294,823	09/2001	Arafa et al.			
	HR	6,307,251	10/2001	Sekikawa et al.			
	IR						
	JR						
	KR						
	LR						
	MR						
	NR						

FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
						Enclosed	No	Enclose	No
	OR	0 747 941 A2	11-1996	Europe	Chan et al.				
	PR	0 785 573-A2	07/1997	Europe	Chan et al.				
	QR								
	RR								
	SR								
	TR								
	UR								
	VR								
	WR								
	XR								

OTHER (Including in this order: Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

	YR								
	ZR								
	AAR								
	BBR								
	CCR								
	DDR								

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.